

Docket No.: P2001,0423



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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Wolfram Köstler et al
Applic. No. : 10/186,970
Filed : July 1, 2002
Title : Wafer Handling System and Wafer Handling Method

ASSOCIATE POWER OF ATTORNEY

Hon. Commissioner of Patents and Trademarks,
Washington, D.C. 20231

Sir:

Please recognize MARKUS NOLFF (Reg. No. 37,006) as my associate in the matter in the above-identified application, with full powers. Please continue addressing all communications to the following address:

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Respectfully submitted,



For Applicants

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Date: July 30, 2002

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